

JPSW

Docket No.: 060188-0775



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Toshihiko UNO : Confirmation Number: 8351
Application No.: 10/784,219 : Group Art Unit: 2815
Filed: February 24, 2004 : Examiner: George C. Eckert
For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 24, 2005, having a three-month shortened statutory period for response set to expire on May 24, 2005, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.

AMENDMENT TO THE TITLE

Please replace the existing title with the following new title: --METHOD OF
MANUFACTURING A SEMICONDUCTOR DEVICE HAVING A HIGH BREAKDOWN
VOLTAGE AND LOW ON-RESISTANCE--